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## APPLICANTS

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## \*\* CONTINUING DATA \*\*\*\*\*

*none G*

## \*\* FOREIGN APPLICATIONS \*\*\*\*\*

JAPAN P2002-223614 07/31/2002  
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## IF REQUIRED, FOREIGN FILING LICENSE GRANTED

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Foreign Priority claimed	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no	STATE OR COUNTRY	SHEETS	TOTAL	INDEPENDENT
35 USC 119 (a-d) conditions met	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance	JAPAN	DRAWING 8	CLAIMS 19	CLAIMS 2
Verified and Acknowledged	<i>K. Tackett</i> <i>Examiner's Signature</i> <i>G</i> Initials				

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## TITLE

Ion implantation method, SOI wafer manufacturing method and ion implantation system

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